

| L Number | Hits | Search Text   | DB  | Time stamp       |
|----------|------|---|---|------------------|
| 6        | 29   | (351/45,51,165.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 13:00 |
| 7        | 218  | (351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 15:27 |
| 8        | 5    | ((359/\$.ccls. and ((interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4))) and (metal\$8 or conductive or conducting)) and lens adj wafer   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 13:05 |
| 9        | 408  | ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer) and (laminat\$4 or cement\$4)) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) and ((multi or multiple or plural\$3) adj layer\$3 or multilayer\$3)) and (mark\$4 or logo or decorat\$4 or relief or pattern) | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 13:08 |
| 11       | 107  | 359/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer) and (laminat\$4 or cement\$4)) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer))   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 14:29 |
| 12       | 25   | 351/\$.ccls. and (lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) near\$3 (filter or coat\$4 or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer)) and (mark\$4 or logo or decorat\$4 or relief or pattern)  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 14:35 |
| 13       | 43   | 359/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive or conducting) adj layer))  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 14:38 |
| 14       | 1    | 351/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive or conducting) adj layer))  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 14:36 |
| 15       | 301  | lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer) with ((metal\$8 or conductive or conducting) adj layer)   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 14:47 |
| 16       | 352  | 351/163.ccls.   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 15:31 |

|    |     |                        |   |                  |
|----|-----|------------------------|---|------------------|
| 20 | 59  | 359/585.ccls. and lens | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 16:28 |
| 21 | 327 | 359/360.ccls.          | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 16:28 |
| 22 | 68  | 359/360.ccls. and lens | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 16:28 |

| L Number | Hits | Search Text   | DB  | Time stamp       |
|----------|------|---|---|------------------|
| 1        | 37   | ((351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)) and plasma | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 11:53 |
| 2        | 15   | 351/\$.ccls. and niobium  | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 11:56 |
| 3        | 57   | 359/585.ccls. and niobium   | USPAT;<br>US-PGPUB;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | 2004/05/07 12:34 |